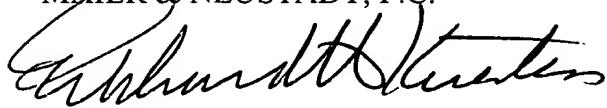


The amendment above serves to correct a clear typographical error on behalf of the Applicants. The correction of this error is consistent with the description of Table 5 on page 67 of the specification.

Respectfully submitted,

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TABLE 5

	SENSE AMPLIFIER PORTION (T41)	PERIPHERAL CIRCUIT PORTION (T42)	MEMORY CELL ARRAY PORTION (T43)
FIELD OXIDE FILM THICKNESS	4000 Å	4000 Å	4000 Å
GATE OXIDE FILM THICKNESS	100 Å	100 Å	100 Å
GATE ELECTRODE FILM THICKNESS	2000 Å	2000 Å	2000 Å
SIDE WALL	1000 Å	1000 Å	1000 Å
WELL	B 700keV $1 \times 10^{13}/\text{cm}^2$	B 700keV $1 \times 10^{13}/\text{cm}^2$	B 700keV $1 \times 10^{13}/\text{cm}^2$
CHANNEL CUT	B 130keV $5 \times 10^{12}/\text{cm}^2$	B 130keV $5 \times 10^{12}/\text{cm}^2$	B 130keV $5 \times 10^{12}/\text{cm}^2$
CHANNEL DOPE	B 50keV $1 \times 10^{12}/\text{cm}^2$	B 50keV $1 \times 10^{12}/\text{cm}^2$	B 50keV $1 \times 10^{12}/\text{cm}^2$
LDD	As 30keV $1 \times 10^{13}/\text{cm}^2$	As 30keV $1 \times 10^{13}/\text{cm}^2$	As 30keV $1 \times 10^{13}/\text{cm}^2$
SOURCE/DRAIN	As 50keV $5 \times 10^{15}/\text{cm}^2$	As 50keV $5 \times 10^{15}/\text{cm}^2$	As 50keV $5 \times 10^{15}/\text{cm}^2$
GATE IMPLANTATION	P 30keV $5 \times 10^{15}/\text{cm}^2$	P 30keV $5 \times 10^{15}/\text{cm}^2$	P 30keV $5 \times 10^{15}/\text{cm}^2$
N 10keV $1 \times 10^{15}/\text{cm}^2$	N 10keV $3 \times 10^{15}/\text{cm}^2$	N 10keV $3 \times 10^{15}/\text{cm}^2$	N 10keV $1 \times 10^{16}/\text{cm}^2$
HEATING		850 °C	60 min

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 Amendment Filed on:
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RE: Application Serial No.: 09/429,283
Applicants: Shuichi UENO, et al.
Filing Date: October 28, 1999
For: SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME
Group Art Unit: 2823
Examiner: Fourson, G. III

SIR:

Attached hereto for filing are the following papers:

SUPPLEMENTAL AMENDMENT WITH MARKED-UP COPY

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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